

# Vacuum Solutions from a single Source



**Applications** 

Know-how



Experience



Customer intimacy



Dimensioning Engineering



Website

eVacuum



#### Service solutions

Worldwide quality



Genuine parts





Training courses Maintenance



Replacement

### Vacuum generation

#### Rotary vane pumps

Single-stage



Pumping speed 250 up to 500 m<sup>3</sup>/h



Pumping speed 25 up to 1,000 m<sup>3</sup>/h



5.4 up to 15 m<sup>3</sup>/h



Pumping speed 22 up to 34 m<sup>3</sup>/h

**Two-stage** 



DuoLine Pumping speed 1.25 up to 250 m<sup>3</sup>/h



MVP 0.25 up to 9.6 m<sup>3</sup>/h

Dia-



XtraDry



HeptaDry Pumping speed 110 up to 525 m<sup>3</sup>/h

Multi-stage Roots pumps

Light duty

ACP 15-40



A100L



load lock pump



ACP 120/ ACG 600 Dry, for industrial



Medium duty

A3P Serie Energy efficient process pump

Turbo pumping stations



Harsh duty

Harsh processes for semiconductor industry

### Roots pumps





OktaLine

250 up to 25,000 m<sup>3</sup>/h 250 up to 12,000 m<sup>3</sup>/h

Roots pumping stations

With two-stage

With single-stage



CombiLine WU



up to 2 · 10<sup>-3</sup> mbar



CombiLine WD up to 5 · 10<sup>-4</sup> mbar



backing pump

With dry

Pascal

Pumping speed 5.4 up to 60 m<sup>3</sup>/h

CombiLine WH up to 2 · 10<sup>-3</sup> mbar



150 up to 1,000 m<sup>3</sup>/h

Side channel pumps



OnTool Booster Pumping speed

#### **Turbopumps**

Hybrid





HiPace 10 up to 2,000 l/s



255 up to 2,600 l/s



ATH M/HiPace M SplitFlow according to requirement





HiCube Eco

35 up to 67 l/s



HiCube Classic 35 up to 685 l/s



35 up to 685 l/s.

High

performance

Vacuum analysis

## Vacuum measurement equipment

ActiveLine

Vacuum measurement



DigiLine





ModulLine measurement for R&D

# Analysis equipment

Residual gas analysis



PrismaPlus Mass range



HiQuad Mass spectromete Mass range 1-2048 amu



Compact benchtop analysis system



coupling with thermo

balances



High Pressure Analyzer Pressure range up to 50 mbar



Sputter Process Monitor Pressure range



Plasma Process

Monitor 1-1024 amu

PPM

Plasma

# Leak detection and leak testing

## Leak detectors

**Portable** 

harsh environments

ASM 310 Mobile, even for





**ASM 142** 

all-rounder

High performance







standard

Vacuum components



devices

ASM 1002 Ergonomical test station

Workstation

ASI 30 Industrial leak detection systems



Modular



**Sniffing leak detection** 



## System technology

Contamination **Management Solutions** 

Plant construction







Multi-stage

vacuum

Classic Coating systems

Coating





TrinosLine

Cubical, horizontal/

vertical, modular

Dry and mobile





Components





Components, valves, manipulators

Glass



Customized

elements

Customized for specific Shut-off valves,

gas dosing valves





Manipulators

Feedthroughs

of contamination

APA

Monitoring





Helium leak

detection



ISO-KF, ISO-K, ISO-F, CF, COF

Hoses and flex

connectors